# Monthly LabAdviser update: 21/6 2013

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| Updated Subject | Contributer | Link to the update pages |
| **Process2Share**  Link to Ph.d. project of Leif Johansen.  Link to Bachelor project of Carsten Bjerre Gade | Leif Johansen @Danchip **Berit G. Herstrøm@ Danchip has added the link to the Bachelor Project of Carsten Bjerrre Gade** | <http://process2share.danchip.dtu.dk/index.php/Projects,_Theses_and_Papers/Ph.D_Projects>  <http://process2share.danchip.dtu.dk/index.php/Projects,_Theses_and_Papers/Bachelor_Projects> |
| **AOE: SiO2 etch with DUV mask**  Selectivity to DUV resist has been tested. | Christian Østergaard @nanotech | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Etching_of_Silicon_Oxide/SiO2_etch_using_AOE#Etching_of_micro_structures_in_Silicon_Oxide_with_photoresist_as_masking_material> |
| **KLA-Tencor Surfscan**  Results from the acceptance test. | Pernille V. Larsen@danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Characterization/KLA-Tencor_Surfscan_6420/Acceptance_test_results> |
| **Measurement of film thickness and optical constants**  Updated comparison page for film thickness and optical constant measurements. | Berit G. Herstrøm@ danchip | http://labadviser.danchip.dtu.dk/index.php/Specific\_Process\_Knowledge/Characterization/Measurement\_of\_film\_thickness\_and\_optical\_constants |